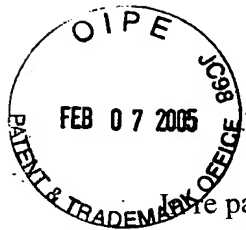


Docket No. GNE518US
ARI.027

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Is the patent application of

Noboru MORITA, et al.

Serial No.: 10/766,921

Group Art Unit: 1765

Filing Date: January 30, 2004

Examiner: Unknown

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING
PLASMA-ENHANCED CVD

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

STATUS INQUIRY

Sir:

Please indicate the status of the above-identified application, including an indication as to when the first Office Action on the merits may be expected.

Respectfully submitted,

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Date: 2/7/05
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